PATENT COOPERATION TREATY

Translation

PCT

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

(Chapter II of the Patent Cooperation Treaty)

(PCT Article 36 and Rule 70)

| Applicant's or agent's file reference JST-122-PCT | FOR FURTHER ACTION | See Form PCT/IPEA/416 | | | | |
|---|---|---|--|--|--|--|
| International application No. | International filing date (day/month/year) | Priority date (day/month/year) | | | | |
| PCT/JP2004/011351 | 06.08.2004 | 11.08.2003 | | | | |
| International Patent Classification (IPC) or natio | onal classification and IPC | | | | | |
| G01N13/16, G12B21/08 | | | | | | |
| Applicant JAPAN SCIENCE AND TEC | CHNOLOGY AGENCY | | | | | |
| This report is the international preling under Article 35 and transmitted to the content of | ninary examination report, established by a applicant according to Article 36. | this International Preliminary Examining Authority | | | | |
| 2. This REPORT consists of a total of | | luding this cover sheet. | | | | |
| 3. This report is also accompanied by A | | | | | | |
| | to the International Bureau) a total of 2 | sheets, as follows: | | | | |
| sheets of the descrip | otion, claims and/or drawings which have b | been amended and are the basis for this report and/or ee Rule 70.16 and Section 607 of the Administrative | | | | |
| sheets which simers | sede earlier sheets, but which this Authority the international application as filed, as indi | y considers contain an amendment that goes beyond cated in item 4 of Box No. I and the Supplemental | | | | |
| | Bureau only) a total of (indicate type and n | number of electronic carrier(s)) | | | | |
| b. (sent to the International | Bureau oray) a total of (mulcale type and in | | | | | |
| | , containing a sequence listing and/or tables related thereto, in computer readable form only, as indicated in the Supplemental Box Relating to Sequence Listing (see | | | | | |
| Section 802 of the Adminis | | | | | | |
| 4. This report contains indications relat | ing to the following items: | | | | | |
| Box No. I Basis of th | e report | | | | | |
| Box No. II Priority | | | | | | |
| | lishment of opinion with regard to novelty, | inventive step and industrial applicability | | | | |
| · — | nity of invention | | | | | |
| Roy No. V Reasoned | • | o novelty, inventive step or industrial applicability; | | | | |
| Box No. VI Certain do | ocuments cited | | | | | |
| Dan No. VIII. Contain de | efects in the international application | | | | | |
| Box No. VII Certain de | | | | | | |
| 1 - | oservations on the international application | | | | | |
| Box No. VIII Certain ob | | on of this report | | | | |
| 1 - | oservations on the international application | on of this report | | | | |
| Box No. VIII Certain ob | oservations on the international application | | | | | |

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

International application No.

PCT/JP2004/011351

| Box | No. I Basis of the | e report | | |
|-----|--|--|-------------------------------------|--|
| 1. | With regard to the languindicated under this item | nage, this report is based on the internation | al application in the language in w | which it was filed, unless otherwise |
| | This report is based on translations from the original language into the following which is the language of a translation furnished for the purposes of: | | | |
| | | search (Rule 12.3 and 23.1(b)) | | |
| | publication o | of the international application (Rule 12.4) | | |
| | | preliminary examination (Rule 55.2 and/o | · | |
| 2. | receiving Office in respo this report): | ents of the international application, this ronse to an invitation under Article 14 are pplication as originally filed/furnished | | |
| | the description: | | | |
| | pages <u>1-24</u> | | | as originally filed/furnished |
| | pages* | | received by this Authority on | |
| | pages* | | received by this Authority on | |
| | the claims: | | | |
| | nos. 9-11 | | | as originally filed/furnished |
| ĺ | nos.* | | as amended (together | r with any statement) under Article 19 |
| | nos.* 2-5,7,8 | 8 | received by this Authority on | 08.06.2005 |
| | nos.* | | received by this Authority on | |
| | the drawings: | | | |
| | sheets 1-22 | | | as originally filed/furnished |
| | sheets* | | received by this Authority on | |
| | sheets* | **** | received by this Authority on | |
| | a sequence listing | and/or any related table(s) - see Supplem | ental Box Relating to Sequence L | isting. |
| 3. | The amendments | have resulted in the cancellation of: | | |
| | the descripti | ion, pages | | |
| | the claims, nos. 1,6 | | | |
| | the drawing | gs, sheets/figs | | |
| | the sequenc | ee listing (specify): | | |
| | any table(s) | related to sequence listing (specify): | | |
| 4. | | een established as if (some of) the amend onsidered to go beyond the disclosure as fi | | |
| | the descript | tion, pages | | |
| | the claims, nos. | | | |
| | the drawing | gs, sheets/figs | | |
| | the sequenc | ce listing (specify): | | |
| | any table(s) | related to sequence listing (specify): | | |
| _* | If item 4 applies, some | or all of those sheets may be marked "sup | erseded." | |

International application No.
PCT/JP2004/011351

| Box No. V Reasoned statement under An citations and explanations suj | | | ticle 35(2) with regard to novelty, inventive step or indu porting such statement | strial applicability; |
|--|-------------------------------|--------|--|-----------------------|
| 1. | Statement | | | |
| | Novelty (N) | Claims | 2-5, 7-11 | YES |
| | | Claims | | NO |
| | Inventive step (IS) | Claims | 2-5, 8-11 | YES |
| | | Claims | 7 | NO |
| | Industrial applicability (IA) | Claims | 2-5, 7-11 | YES |
| | | Claims | | NO |
| | | | | |

- 2. Citations and explanations (Rule 70.7)
 - Document 1: JP 6-267408 A (Canon Inc.), 22 September 1994, entire text; all drawings
 - Document 2: JP 10-239325 A (Seiko Instruments, Inc.), 11
 September 1998, entire text; all drawings
 - Document 3: JP 2002-5810 A (Canon Inc.), 9 January 2002, entire text; all drawings
 - Document 4: JP 2003-114182 A (Japan Science and Technology Corporation), 18 April 2003, entire text; all drawings

Claims 2 to 5 and 8 to 11

Document 1 sets forth the probe of a probe microscope using a transparent substrate, constituted so as to enable optical observation and/or measurement from the rear surface of the transparent substrate, and provided with a probe having a cantilever which is supported so as to be held a predetermined distance from the surface, on the surface of one side of the transparent substrate.

Document 2 sets forth a similar probe, and a transparent substrate which is constituted to allow optical measurement and/or observation, while partitioning the environment inside and outside the

PCT/JP2004/011351

Box No. V Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement

container.

In addition, in the probe set forth in document 1, the cantilever forms a multilayer structure comprising a cantilever main body (5) and a second reflective layer (4) (and an electrode (10)), therefore internal stress is applied. Moreover, [fig. 4] and [fig. 5] indicate that the interval between the cantilever and the transparent substrate becomes gradually wider from the root part to the tip of the cantilever.

Moreover, document 4 indicates that the cantilever is excited by rays of light.

However, a probe for a probe microscope which uses a transparent substrate, wherein a microlens is formed on part of the aforementioned transparent substrate, and rays of light for optical driving or observation/ measurement of the cantilever are converged on the rear surface of the cantilever by the aforementioned microlens, is not disclosed in any of the documents cited in the international search report, and would not be obvious to a person skilled in the art.

Claim 7

Document 3 (see paragraph [0025] and [fig. 5] in particular) sets forth a method of producing a probe, wherein a lever shape is fabricated on a single crystal silicon thin-film layer of an SOI substrate, the reverse side of the SOI substrate is connected to another substrate, and the handling wafer and embedded oxide film are removed.

In addition, the inventions set forth in documents 1 and 3 relate to the same technical field of probe microscopes, and in said technical field it is a known

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

International application No.
PCT/JP2004/011351

| Box | No. V | Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement |
|-----|--------|---|
| | techni | ique to form a probe by wet etching, therefore it |
| | would | be obvious to a person skilled in the art to employ |
| | the pr | roduction method set forth in document 3 as the |
| j | produc | ction method for the probe set forth in document 1, |
| | and to | o form the probe by wet-etching, to constitute the |
| | invent | tion set forth in claim 7. |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| l | | |
| | | |
| | | |
| | | |
| | | |
| 1 | | |